IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: TO BE ASSIGNED Group Art Unit: TO BE ASSIGNED Filed: August 5, 2003 Examiner: For: MAGNETRON, AND MICROWAVE OVEN AND HIGH-FREQUENCY HEATING APPARATUS EACH EQUIPPED WITH THE SAME INFORMATION DISCLOSURE STATEMENT Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450 Sir: In accordance with the duty of disclosure provisions of 37 CFR § 1.56, there is hereby provided certain information which the Examiner may consider material to the examination of to subject U.S. patent application. It is requested that the Examiner make this information of record if it is deemed material to the examination of the subject application.	In re Patent Appl	lication of:	
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 Enclosures accompanying this Information Disclosure Statement are: 	1. E	nclosures accompanying this Inforr	nation Disclosure Statement are:
 1a.	1b.	Copies of IDS citations. An English language copy of seapplication or a PCT Internation English language translation (A language publication. Explanations of Relevancy of F	nal Search Report. Abstract Only) attached to each non-English References (ATTACHMENT 1(e), hereto) for
2. In accordance with 37 CFR § 1.98, a concise explanation of what is presently understood to be the relevance of each non-English language publication is	2. 🛭 I	In accordance with 37 CFR § 1.98, understood to be the relevance of e	a concise explanation of what is presently each non-English language publication is
(Check appropriate Items 2a, 2b, 2c and/or 2d) 2a. satisfied because all non-English language publications were cited on the enclosed "English-language version of the search report or action which indicates the degree of relevance found by the foreign office". (See MPE 609, Minimum Requirements for an Information Disclosure Statement, Pa A(3): Concise Explanation of Relevance, pp. 600-100 to 600-101, Rev. 1, Feb. 2000.) 2b. set forth in the application.	_	satisfied because all non-Engli enclosed "English-language ve indicates the degree of relevan 609, Minimum Requirements for A(3): Concise Explanation of R Feb. 2000.)	sh language publications were cited on the ersion of the search report or action which ace found by the foreign office". (See MPEP or an Information Disclosure Statement, Part

	2c. 🔀	attached to each non-English language publication. enclosed as Attachment 1(e), hereto.
3.	to be, m (other th	ission is made that the information cited in this Statement is, or is considered naterial to patentability nor a representation that a search has been made nan search report(s) from a counterpart foreign application or a PCT ional Search Report, if submitted herewith). 37 CFR §§ 1.97(g) and (h).
		Respectfully submitted,

STAAS & HALSEY LLP

Dated: August 5, 2003 1201 New York Ave., N.W., Suite 700

Washington, D.C. 20005 Telephone: (202) 434-1500 Facsimile: (202) 434-1501

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO.	APPLICATION NO.
1594.1226	TO BE ASSIGNED
FIRST NAMED INVENTOR	
Jong-Chull SHON et al.	

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

I INST INMED INVENTOR	
Jong-Chull SHON et al.	
FILING DATE	GROUP ART UNIT
August 5, 2003	TO BE ASSIGNED

U.S. PATENT DOCUMENTS

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA					1	
	АВ						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

	DOCUMENT		THE DOCUMENTS	T	CLID	TDANO	ATION
	NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANS YES	NO NO
AG	2002-163992	6/7/2002	Japan			ABS.	
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OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

AM	Park, Seung-Ho, Korean Patent Abstract Publication No. 1019930000576, Publication Date 19930125, Application No. 1019900014950, Application Date 19900920, Abstract only
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DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.